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	10625201
	2003-07-22
Davis	, Jason
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	Filing Date		2003-07-22	
	First Named Inventor Davis		, Jason	
	Art Unit		2624	
	Examiner Name	e, John B		
	Attorney Docket Numb	er	C03-002	

	9	6070160		2000-05-30	Geary, Wade et al			
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